

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.
278591US0PCTSERIAL NO.
10/549,848

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Atsushi IWATA, et al.

FILING DATE

September 19, 2005

GROUP

1792

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
|---------------------|----|--------------------|------|------|-------|--------------|-------------------------------|
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
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| | AL | | | | | | |
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| | AN | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | DATE | COUNTRY | TRANSLATION | |
|--|----|--------------------|----------|----------------------------|-------------|----|
| | | | | | YES | NO |
| | AO | 55-056004 | 04/24/80 | JP (with English abstract) | | NO |
| | AP | 58-204809 | 11/29/83 | JP (with English abstract) | | NO |
| | AQ | | | | | |
| | AR | | | | | |
| | AS | | | | | |
| | AT | | | | | |
| | AU | | | | | |
| | AV | | | | | |

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

| | | | | | | |
|--|----|--|--|--|--|--|
| | AW | AKEWATASHI, Jun et al., Ceramic Thin Film Formation Technology Using Collision and Solidification Phenomena of Particles and Ultra-fine Particles.- Aerosol Deposition Method for High Speed Coating at Low Temperature, National Institute of Advanced Industrial Science and Technology, Tsukuba, Pages 459 - 466, 2002, with Partial English Translation. | | | | |
| | AX | KIM, I.W. et al., Critical Thickness for Transformation of Epitaxially Stabilized Cubic AlN in Superlattices, Applied Physics Letters, Vol. 78, No. 7, Pages 892 - 894, 2001. | | | | |
| | AY | MASHIMO, Tsutomu et al., Yield Properties, Phase Transition, and equation of State of Aluminum Nitride (AlN) Under Shock Compression up to 150 GPa., Journal of Applied Physics, Vol. 86, No. 12, Pages 6710 - 6716, 1999. | | | | |
| | AZ | | | | | <input type="checkbox"/> Additional References sheet(s) attached |

Examiner /Felisa Hiteshew/

Date Considered 04/18/2008

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /F.H./



U.S. PCT Application Serial No: 10/549,848

Filed: September 19, 2005

Atsushi IWATA, et al.

Docket No. 278591 US

STATEMENT OF RELEVANCY

- 1) References AO - AP have been cited in the International Search Report. A copy of these references is being submitted herewith.
- 2) References have been cited in the corresponding Search Report. A copy of these references is being submitted herewith.
- 3) References AW - AY are discussed in the specification. A copy of these references is being submitted herewith.
- 4) References are additional prior art known to Applicant. A copy of these references is being submitted herewith.